# Monthly LabAdviser update: 1/10 2014

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| Updated Subject | Contributor | Link to the updated pages |
| **III-V profiler**  Moved to Characterization entry in LabAdviser | **Katharina Nilson**  **@danchip** | [Profiler#Dektak\_III-V\_Profiler](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Characterization/Profiler#Dektak_III-V_Profiler) |
| **Physimeca**  Moved to Thin film deposition entry in LabAdviser | **Katharina Nilson @danchip** | [Physimeca](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/Physimeca) |
| **III-V evaporator**  Moved to Thin film deposition entry in LabAdviser | **Katharina Nilson**  **@danchip** | [III-V\_Dielectric\_evaporator](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/III-V_Dielectric_evaporator) |

# Equipment Manuals updated in LabManager:

* [**Manual for MVD**](http://d4.danchip.dtu.dk/D4Doc/book/docshow.asp?DokID=1677&sText=)
* [**Manual for Hotplate: 90-110C**](http://d4.danchip.dtu.dk/D4Doc/book/docshow.asp?DokID=3510&sText=)
* [**Manual for Developer TMAH UV-lithography**](http://d4.danchip.dtu.dk/D4Doc/book/docshow.asp?DokID=3561&sText=)
* [**Manual for Technotrans nickel plating machine**](http://d4.danchip.dtu.dk/D4Doc/book/docshow.asp?DokID=3295&sText=)
* **Manual for AOE**

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